

Docket Number: 071469-0308969
Client Reference: FKL-020

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

NORIAKI FUKIAGE

Group Art Unit:

Application No.:

Examiner:

Filed: March 30, 2004

Confirmation No.:

For: Method of Improving the Wafer to Wafer Uniformity and Defectivity of a Deposited Dielectric Film

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

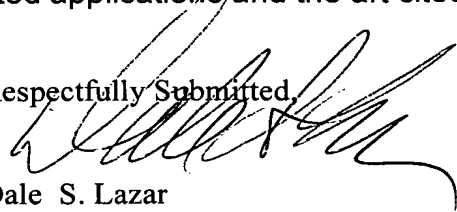
Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. As this application is being filed after June 30, 1993, no copies of the cited U.S. patents have been enclosed. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

As this Information Disclosure Statement is being filed with the application, no certification or fee is required.

This application is one of a series of related applications, identified in the attached Appendix, which are directed to related technical subject matter. The identification of those U.S. Patent Applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination.

Respectfully Submitted,



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Date: March 30 2004
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APPENDIX

Examiner's Initials	First Inventor	Application No.	Filing Date	Enclosed
	FUKIAGE	10/644,958	8/21/03	<input checked="" type="checkbox"/> Specification <input checked="" type="checkbox"/> Drawings
	FUKIAGE	10/702,048	11/6/03	<input checked="" type="checkbox"/> Specification <input checked="" type="checkbox"/> Drawings
	FUKIAGE	10/702,043	11/6/03	<input checked="" type="checkbox"/> Specification <input checked="" type="checkbox"/> Drawings

The Examiner's initials indicates he/she has considered the cited application relative to the subject application.

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Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1 of

Complete if Known

Application Number	
Filing Date	03/30/2004
First Named Inventor	Noriaki FUKIAGE
Art Unit	
Examiner Name	
Attorney Docket Number	071469-0308969

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)				
	1	US- 6,374,831	B1	04-23-2002	CHANDRAN et al.	
	2	US- 6,387,207	B1	05-14-2002	JANAKIRAMAN et al.	
	3	US- 6,329,297	B1	12-11-2001	BALISH et al.	
	4	US- 5,788,778		08-04-1998	SHANG et al.	
	5	US- 6,109,206		08-29-2000	MAYDAN et al.	
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FOREIGN PATENT DOCUMENTS

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Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				

Examiner
SignatureDate
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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